

Notice of References Cited	Application/Control No. 10/628,988	Applicant(s)/Patent Under Reexamination LIN ET AL.	
	Examiner Arnel C. Lavarias	Art Unit 2872	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-3,770,886	11-1973	Kiemle, Horst	369/14
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	C	US-			
	D	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	<i>NONE</i>				
	O					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	<i>NONE</i>
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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